



#### PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q73500

Masahiro AMEMIYA, et al.

Appln. No.: 10/538,929

Group Art Unit: 1751

Confirmation No.: 5996

Examiner: UNKNOWN

Filed: June 13, 2005

For:

CLEANING AGENT COMPOSITION, CLEANING AND PRODUCTION METHODS

FOR SEMICONDUCTOR WAFER, AND SEMICONDUCTOR WAFER

## <u>INFORMATION DISCLOSURE STATEMENT</u> <u>UNDER 37 C.F.R. §§ 1.97 and 1.98</u>

#### MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure under 37 C.F.R. § 1.56, Applicant hereby notifies the U.S. Patent and Trademark Office of the documents which are listed on the attached PTO/SB/08 A & B (modified) form and/or listed herein and which the Examiner may deem material to patentability of the claims of the above-identified application.

One copy of each of the listed documents is submitted herewith, except for the following: U.S. patents and/or U.S. patent publications; and co-pending non-provisional U.S. applications filed after June 30, 2003. Also, Applicant encloses herewith a copy of two Communications from foreign patent offices in counterpart applications citing such documents.

The present Information Disclosure Statement is being filed: (1) No later than three months from the application's filing date; (2) Before the mailing date of the first Office Action on the merits (whichever is later); or (3) Before the mailing date of the first Office Action after filing a request for continued examination (RCE) under §1.114, and therefore, no Statement under 37 C.F.R. § 1.97(e) or fee under 37 C.F.R. § 1.17(p) is required. However, since a

INFORMATION DISCLOSURE STATEMENT

U.S. Appln. No.: 10/538,929

statement can be filed, one is being filed in the event an Office Action has been issued but not

vet received.

In compliance with the concise explanation requirement under 37 C.F.R. § 1.98(a)(3) for

foreign language documents, Applicant submits the following explanation: The submission of

corresponding US Patent 5,302,313 for KR-B1-1995-0013923 constitutes a concise statement of

relevance of KR-B1-1995-0013923.

The submission of the listed documents is not intended as an admission that any such

document constitutes prior art against the claims of the present application. Applicant does not

waive any right to take any action that would be appropriate to antedate or otherwise remove any

listed document as a competent reference against the claims of the present application.

The USPTO is directed and authorized to charge all required fees, except for the Issue

Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any

overpayments to said Deposit Account.

Respectfully submitted,

Registration No. 33,725

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WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: July 14, 2006

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## STATEMENT UNDER 37 C.F.R. § 1.97(e)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of said Information Disclosure Statement.

Respectfully submitted,

Registration No. 33,725

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Date: July 14, 2006

Complete if Known

Substitute for Form 1449 A & B/PTO

		17	. J. F.	Application Number	10/538,929
INFO	RMATION	DISCHOST	RE	Confirmation Number	5996
STATEMENT BY APPLICANT				Filing Date	June 13, 2005
				First Named Inventor	Masahiro AMEMIYA
(use as many sheets as necessary)			•	Art Unit	1751
				Examiner Name	UNKNOWN
Sheet	1	of 1		Attorney Docket Number	Q73500

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite	Document Number		Dublication Date		
	No.1	Number	Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	
_		US 2001/0025017	Al	09-27-2001	Amemiya et al.	
		US 5,302,313		04-12-1994	Asano et al.	
		US 6,417,147	B2	07-09-2002	Amemiya et al.	
		US				
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FOREIGN PATENT DOCUMENTS							
Cite	Foreign Patent Document			Publication Date	Name of Patentee or		
No.1	Country Code <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)	MM-DD-YYYY	Applicant of Cited Document	Translation <sup>6</sup>	
	KR	1995-0013923	BI	11-18-1995	ASAHI GLASS COMPANY LTD.	Corrresponding US Patent 5,302,313 cited above	
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	Cite No.1	No. 1 Country Code <sup>3</sup>	Cite No. 1  Country Code 3  Number 4	Cite No. 1 Country Code 3 Number 4 Kind Code 5 (if known)	Cite No. 1 Country Code 3 Number 4 Kind Code 5 (if known) Publication Date MM-DD-YYYY	Cite No. 1 Foreign Patent Document Publication Date Name of Patentee or Applicant of Cited Document  KR 1995-0013923 B1 11-18-1995 ASAHI GLASS COMPANY	

	NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation <sup>6</sup>			

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Examiner Signature		Date Considered	

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>&</sup>lt;sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup>See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or follow the hyperlink from the title of the document to the intranet. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to indicate here if English language Translation is attached.